

INFORMATION DISCLOSURE CITATION	ATTY. DOCKET NO. 2826-11	SERIAL NO. 10/078,382
	APPLICANT SONG et al.	GROUP 1762-1765
(Use several sheets if necessary)		

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)

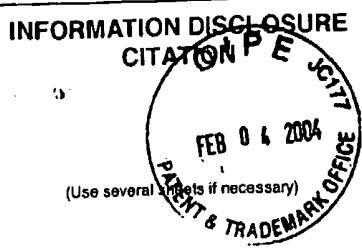
*Examiner

Druta K. Hanks

3/7/04
Date Considered

3/7/04

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February 21, 2002	1765

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✓ 104	High-Speed, Maskless Laser Patterning of Indium Tin Oxide Thin Films, O. Yavas et al., Applied Physics Letters, Vol. 73, No. 18, 11/2/98, pages 2558-2560.
✓	Effect of Substrate Absorption on the Efficiency of Laser Patterning of Indium Tin Oxide Thin Films, O. Yavas et al., Journal of Applied Physics, Vol. 85, No. 8, April 15, 1999, pages 4207-4212.
✓	Substrate-Assisted Laser Patterning of Indium Tin Oxide Thin Films, O. Yavas et al., Appl. Phys. A69, S875-S878, July 1999.
✓	Laser-Induced Etching of Polycrystalline Al_2O_3 TiC in KOH Aqueous Solution, Lu et al., Appl. Phys., pages 43-49, received March 6, 1995, Accepted June 26, 1995.
✓	Efficient Pulsed Laser Removal of $0.2 \mu m$ Sized Particles from a Solid Surface, Appl. Phys. Letter, Vol. 58, No. 20, May 20, 1991, W. Zapka et al.

*Examiner

Anita K. Hensel

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3/18/04

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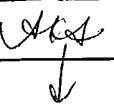
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FEB 04 2004



	Laser-Assisted Micron Scale Particle Removal, Appl. Phys. Lett., Vol. 58, No. 2, January 14, 1991, Imen et al., pages 203-205.
	Laser-Cleaning Techniques for Removal of Surface Particulates, J. Appl. Phys., Vol. 71, No. 7, April 1, 1992, Tam et al., pages 3515-3523.

*Examiner

Anita K. Alanko

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